A Hazardous Gas Detection System for Aerospace and Commercial Applications

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A HAZARDOUS GAS DETECTION SYSTEM FOR AEROSPACE AND COMMERCIAL APPLICATIONS

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ABSTRACT

The detection of explosive conditions in aerospace propulsion applications is important for safety and economic reasons. Microfabricated hydrogen, oxygen, and hydrocarbon sensors as well as the accompanying hardware and software are being developed for a range of aerospace safety applications. The development of these sensors is being done using MEMS (Micro ElectroMechanical Systems) based technology and SiC-based semiconductor technology. The hardware and software allows control and interrogation of each sensor head and reduces accompanying cabling through multiplexing. These systems are being applied on the X-33 and on an upcoming STS-95 Shuttle mission. A number of commercial applications are also being pursued. It is concluded that this MEMS-based technology has significant potential to reduce costs and increase safety in a variety of aerospace applications.

INTRODUCTION

The detection of explosive combinations of fuel and oxygen is important in the aerospace industry for safety monitoring applications. Specifically, leaks in fuel tank systems can lead to hazardous situations. If the leak location and magnitude cannot be determined in a timely manner, the consequences can range from expensive delays to loss of life. For example, in 1990, the leaks on the Space Shuttle while on the launch pad temporarily grounded the fleet until the leak source could be identified.

In response to the hydrogen leak problems in particular, NASA endeavored to improve propellant leak detection capabilities during assembly, pre-launch operations, and flight. The objective has been to reduce the operational cost of assembling and maintaining hydrogen delivery systems by using automated detection systems. Specifically, efforts were made to develop an automated hydrogen leak detection system using point-contact hydrogen sensors. However, no commercial sensors existed at that time that operated satisfactorily in this application. The reason for this is the conditions in which the sensor must operate.

The hydrogen sensor must be able to detect hydrogen from low concentrations through the lower explosive limit (LEL) which is 4% in air. The sensor must be able to survive exposure to 100% hydrogen without damage or change in calibration. Further, the sensor may be exposed to gases emerging from cryogenic sources. Thus, sensor temperature control is necessary. Operation in inert environments is necessary since the sensor may have to operate in areas purged with helium. If a number of sensors are to be placed in an area, then size, weight, and power consumption for each sensor becomes an issue. Commercially available sensors, which often needed oxygen to operate or depended upon moisture, did not meet the needs of this application and thus the development of new types of hydrogen sensors was necessary.

However, it is not just the concentration of hydrogen that determines if an explosive condition exits but the corresponding concentration of oxygen as well.
Thus, the simultaneous measurement of oxygen as well as hydrogen is desirable in safety applications. Further, the needs of future aerospace applications may require not only the detection of hydrogen but other hydrocarbon fuels which may be used as propellants. For example, the use of methane or kerosene as propulsion fuels means that the detection of these hydrocarbons in inert environments may be necessary for leak detection for future propulsion systems. These sensor technologies would have to meet the same requirements as the hydrogen sensor technology of minimal size, weight, and power consumption. Miniaturized, integrated hydrocarbon leak detection technology of this type does not presently exist.

In conjunction with improved sensor technology, a complete leak detection system also needs accompanying hardware and software. Being able to multiplex the signal from a number of sensors so as to "visualize" the magnitude and location of the leak is necessary. The hardware should be multiplexed to limit the amount of cabling necessary to operate the system and intelligent control of each sensor head is required.

NASA Lewis Research Center (LeRC), Case Western Reserve University (CWRU), and Makel Engineering Inc. (MEI) are actively involved in developing leak sensor technology as well as the corresponding hardware and software to meet the needs of aerospace applications. The sensor fabrication is performed using MEMS (Micro ElectroMechanical Systems) based technology i.e. using silicon (Si) integrated circuit processing technology. This results in miniaturized sensors which can be micro-machined for minimal size, weight, and power consumption. Also being explored are sensors which use high temperature silicon carbide (SiC) semiconductors. Smart electronics are included with the system to provide temperature control for the sensor and to interpret the sensor output.

The purpose of this paper is to discuss the development of this technology. We will first discuss the development of hydrogen, oxygen, and hydrocarbon sensor technology. We will then discuss the hardware and software associated with the hydrogen sensor technology and the current application of this technology to X-33 applications and to the Space Shuttle mission STS-95. Potential commercial applications of these technologies are also discussed. It is concluded that the continued development of this technology will enable improved safety for flight propulsion applications.

**HYDROGEN DETECTION**

One component of the sensor development program at NASA LeRC and CWRU in conjunction with MEI involves the development of palladium (Pd) alloy Schottky diodes on silicon (Si) substrates. These sensors are designed to detect hydrogen (H₂) in space applications. This type of sensor is based on metal-oxide-semiconductor (MOS) technology such as that used in the semiconductor electronics industry. The gas sensing MOS structures are composed of a hydrogen sensitive metal deposited on an insulator adherent to a semiconductor. This forms a Schottky diode in the case of a very thin layer of insulator. The most common MOS structure used for hydrogen detection is the Pd-SiO₂-Si structure. Hydrogen disassociates on the Pd surface and diffuses to the Pd-SiO₂ interface affecting the electronic properties of the MOS system. The use of pure Pd at near room temperatures as the hydrogen sensitive metal is problematic for several reasons. The most serious of these involves a phase change that occurs at high hydrogen concentrations which can lead to hysteresis or film damage.

Schottky diodes using Pd alloys as the hydrogen sensitive metal are presently being fabricated. The first generation of these sensors used palladium silver (PdAg). The use of PdAg in hydrogen sensing applications was pioneered by Hughes. Palladium silver has advantages over Pd. Palladium silver is more resistant to damage from exposure to high hydrogen concentration than Pd. Furthermore, the alloy has faster response times than Pd.

The sensor structure is shown in Figure 1 with a picture of the packaged sensor. The structure includes a Pd alloy Schottky diode, a temperature detector, and a heater all incorporated in the same chip. The sensor is fabricated using a n-type silicon wafer on which approximately 50 Å of silicon dioxide (SiO₂) is thermally grown in the sensor region. The heater and temperature detector are platinum covered with SiO₂. Gold leads are applied by thermal compression bonding and the sensor is mounted on a TOS5 header or on a ceramic flat package. The surface area of the Schottky diode is 6.1x10⁻¹³ cm² and the complete sensor dimensions are approximately 2.2 mm on a side. The response of the Schottky diodes was determined by measuring the diode's reverse current.
The properties of the PdAg sensor make it very useful for applications where sensing small amounts of hydrogen is necessary. The sensor responds in an inert environment (no oxygen) to the presence of hydrogen. The presence of oxygen decreases the sensor response but the sensor is still sensitive to low concentrations of hydrogen. The sensor response is large, rapid, and repeatable. If quick recovery is necessary, then the sensor should be operated in oxygen containing gases. If detection of hydrogen is required without rapid recovery, then this sensor can also be used in inert environments. The sensor responds to hydrogen across a wide concentration range with a signal and response time that is temperature dependent. This sensor can be used to monitor leaks in a multipoint leak detection scheme involving a number of these sensors. Further, this PdAg sensor has been shown to have a sensitivity and response comparable to that of a mass spectrometer.

Although the PdAg sensor showed excellent properties for a number of applications, exposure to higher temperatures and higher hydrogen concentrations changed the sensor calibration and occasionally led to sensor failure. An example of the degradation of the PdAg sensor response at higher temperatures and higher hydrogen concentrations is shown in Figure 2. The response of a PdAg sensor to 100% hydrogen at 100°C for several cycles is shown. The sensor response decreases with the number of exposures and with a much poorer recovery to the original baseline after each cycle.

One significant reason for this behavior may be seen in Figure 3. Figure 3 shows an optical micrograph (400x) of an as-deposited PdAg sensing pad of the Schottky diode (Figure 3a) and a sensing pad from the PdAg sensor (Figure 3b) characterized at 100°C in 100% hydrogen in Figure 2. The as-deposited PdAg film is uniform in surface features and the edges of the film are straight and rectangular. In contrast, the PdAg film in the characterized sample shows significant peeling of the PdAg near the edges of the sensor pads, a rectangular pattern and a significant amount of surface features. EDAX (Energy Dispersion Analysis of X-Radiation) analysis of the region near the edge of the sensor pad in Figure 3b suggests that the PdAg has been removed from the surface leaving only the SiO2 layer. Thus, a likely reason for the change in the sensor response with heating and exposure to 100% hydrogen is this delamination of the PdAg sensing film near the edges of the sensor pad.
Therefore, the sensor structure needs to be stabilized for operation in 100% hydrogen (as in the Shuttle application). This led to the development of the next generation of sensor. This sensor, which uses PdCr as the hydrogen sensitive alloy, is in its later stages of development. The response of the PdCr Schottky diode to 100% hydrogen at 100°C is also shown in Figure 2. The PdCr sensor is much more stable than the PdAg sensor under these conditions; the PdCr diode response to 100% hydrogen is nearly consistent (after the initial exposures) with an equally consistent return to a common baseline. The optical micrograph of the corresponding PdCr sensor pad (Figure 3c) shows some degradation of the film surface. However, the PdCr film does not exhibit the peeling of the sensing film near the edge of the sensing pad as was seen with the PdAg film.

Parallel tests to those of Figure 2 were conducted at 100% hydrogen with a different PdCr sensor and an operating temperature of 75°C. The PdCr sensor response was similar to that seen in Figure 2. However, as seen in Figure 3d, there is significantly less surface structure on the sensor film surface with generally good adhesion of the film to the rectangular boundaries of the sensor pad.

Therefore, PdCr shows significantly improved stability and response over PdAg at 100°C. Operation at 70°C results in more stable surface features than 100°C operation. The results of these tests and other testing suggest that PdCr is better for applications where the sensor is exposed to higher hydrogen concentrations while PdAg can be used for lower hydrogen concentration applications.

This has led to the use of PdCr both as a hydrogen sensitive resistor and a Schottky diode material to expand the detection range of the sensor for X-33 applications (Figure 1): a Schottky diode provides sensitive detection of low concentrations of hydrogen while the resistor provides sensitivity up to 100% hydrogen.

The resistors have been fabricated so as to have the highest sensitivity to concentrations of hydrogen greater than 1%. This is shown in Figure 4 for 7 resistive sensors exposed to hydrogen in nitrogen from 10 ppm to $1\times10^6$ ppm (100%). The resistor response is conditioned by electronics to result in changes in millivolts (mV) as shown in the Figure. The signal increases significantly with higher concentrations of hydrogen and the response of the 7 resistors is seen to be generally uniform.

![Figure 3. Optical Micrographs of the sensor pad of: a) PdAg as-deposited; b) PdAg sensor after heating and characterization in 100% H₂ at 100°C; c) PdCr sensor after heating and characterization in 100% H₂ at 100°C; d) PdCr sensor after heating and characterization in 100% H₂ at 75°C. The PdCr sensor does not show delamination of the sensor film near the edges of the sensor pad evident with the PtAg-based sensor.](image-url)
Therefore, two alloys are used to measure hydrogen in inert environments. Palladium silver can be used for sensitive measurement of low concentrations of hydrogen while PdCr can be used as a diode and resistor material for a range of concentrations up to 100% hydrogen.

**OXYGEN DETECTION**

The development of a microfabricated O$_2$ sensor has been initiated to complement the existing hydrogen sensor technology. Commercially available oxygen sensors are typically electrochemical cells using zirconium dioxide (ZrO$_2$) as a solid electrolyte and Pt as the anode and cathode. The anode is exposed to a reference gas (usually air) while the cathode is exposed to the gas to be detected. Zirconium dioxide becomes an ionic conductor of O$_2$ at temperatures of 600°C and above. This property of ZrO$_2$ to ionically conduct oxygen means that the electrochemical potential of the cell can be used to measure the ambient oxygen concentration at high temperatures. However, operation of these commercially available sensors in this potentiometric mode limits the range of oxygen detection. Typically, the potentiometric mode has limited sensitivity above 1% oxygen. Further, the current manufacturing procedure of this sensor, using sintered ZrO$_2$, is relatively labor intensive and costly resulting in a complete sensor package with a power consumption on the order of several watts.

The objective of this research is to develop a zirconium dioxide solid electrolyte oxygen sensor using microfabrication and micromachining techniques. A schematic of the sensor design is shown in Figure 6 with a picture of the packaged sensor. A diaphragm region is micro-machined by etching beneath the sensing area. Microfabricating the sensor components onto the diaphragm region allows the sensor to be small in size and have decreased energy consumption and time for thermal equilibrium. When operated in the amperometric mode, the current of this cell is a linear function of the ambient oxygen concentration. This linear response to oxygen concentration significantly increases the oxygen detection range of the sensor. A chamber structure with a well-defined orifice is micromachined to cover the sensing area. This orifice provides a pathway to control oxygen diffusion which is important in amperometric measurements. This orifice also protects the integrity of the sensing electrode from impinging particles. Preliminary testing of a complete oxygen sensor has been accomplished and further improvements on the design are planned.
The completed oxygen sensor will be incorporated into one sensor package with the existing PdCr hydrogen sensor. The combined system will be able to measure the concentration of hydrogen and oxygen simultaneously. The ratio of the hydrogen to oxygen concentration will not only determine if there is a leak but if there is an explosive condition. However, if the fuel is not hydrogen, leak detection of the fuel in inert environments using point-contact sensors is not presently commercially available. Thus, the development of corresponding hydrocarbon leak sensor technology is necessary.

HYDROCARBON DETECTION

The development of hydrocarbon sensors for use in safety applications has centered on the development of a stable SiC-based Schottky diode. There are significant advantages in a number of gas sensing applications to using SiC as the semiconductor rather than Si. These advantages are due to the improved material properties of SiC over Si such as high temperature semiconductor operation, superior mechanical toughness, and increased thermal conductivity. The detection of gases such as hydrocarbons, which decompose at high temperatures, is facilitated by heating the sensor to the gas decomposition temperature. The hydrocarbons then dissociate and produce atomic hydrogen. The resulting atomic hydrogen affects the sensor output in the same way as molecular hydrogen.

The SiC-based Schottky diode structure under development has begun with Pd on SiC (Pd/SiC) MS structures. Direct contact between the gas sensitive catalytic metal and the semiconductor allows changes in the catalytic metal to have maximum effect on the semiconductor. Studies of this baseline system help determine limits of diode sensitivity, potential material interactions between Pd and SiC, and whether a barrier layer between the Pd and SiC is necessary for long-term sensor stability. The details of this work are reviewed elsewhere. The sensor detects hydrogen and hydrocarbons in inert or oxygen containing environments.

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However, the Pd/SiC sensor response is affected by extended high temperature heating. Prolonged heating at 425°C has been shown to change the sensor properties and to decrease sensor sensitivity. Even after heating at 425°C in air for 140 hours, the Pd/SiC Schottky diode is still very sensitive to the presence of hydrogen: a factor of 1000 change in forward current is observed upon exposure to 1000 ppm hydrogen in He. The reason for this change in diode properties is likely due to reactions between the Pd and SiC at the interface upon heating. Nonetheless, efforts have been underway to stabilize the sensor structure for long-term, high temperature operation.

One new structure demonstrated which has improved stability over that of Pd/SiC is PdCr directly deposited on SiC (PdCr/SiC). The advantages of PdCr as a high temperature alloy have been explored extensively in strain gage applications. It is a stable high temperature material which is able to provide static strain measurements at temperatures up to 1100°C. However, its use in a gas-sensing SiC-based structure depends on not only its inherent stability but also such factors as the alloy’s reactivity to SiC and the catalytic interactions of PdCr alloy with the gases to be measured.

The response of a PdCr/SiC diode to long term heating of 250 hours at 425°C showed improved stability over Pd/SiC. Monitoring of the sensor performance periodically during the heating period suggests the PdCr/SiC diode has improved stability over the Pd/SiC structure. The sensor is characterized at 100°C after heating at 425°C. Current-time measurements at 0.7 V were taken as the sensor was exposed to 20 minutes of air, 20 minutes in nitrogen (N₂), 20 minutes of 120 ppm H₂ in N₂ (N₂/H₂ mix), 10 minutes of N₂, and then 10 minutes of air. After an initial break-in period of near 40 hours, the results show that the sensor response in hydrogen is relatively constant.

This is illustrated in Figure 8 where the diode response after 40 and 250 hours of heating is compared. Although the sensor baseline in air is much lower after 250 hours of heating than at 40 hours, the sensor current in the N₂/H₂ mix is the same within a factor of 3. Thus, the diode’s response to hydrogen after 250 hours of heating is nearly two orders of magnitude larger at this voltage than at 40 hours.

Therefore, the high sensitivity and improved stability of the PdCr/SiC sensor allows the sensitive detection of hydrogen. The use of SiC as a semiconductor expands the temperature range of hydrogen detection and also allows the detection of hydrocarbons. Testing of the PdCr alloy at high temperature is planned to determine the diode’s sensitivity to a range of hydrocarbons. Future work will also include packaging of the SiC-based sensor for leak detection applications.
The initial incorporation of the PdAg sensor into hardware and software has been reported elsewhere. MEI, CWRU, and NASA LeRC have subsequently developed a “Smart Sensor” for hydrogen gas detection under an STTR contract from NASA MSFC. A broad range of operational system payoffs are possible with this type of complete leak detection system. These payoffs include: 1) Improved Integrated Vehicle Health Management (IVHM); 2) Improved safety and reliability; 3) Reduced sensor size and weight yielding reduced vehicle weight; 4) Cost effective method to instrument the vehicle.

Current aerospace applications of the Pd alloy sensors include the hydrogen leak detection systems for NASA’s X-33 Flight Demonstrator and an upcoming Space Shuttle technology demonstration flight for STS-95. For these applications robust signal conditioning and control electronics have been developed to operate the sensors. A block diagram of our desired functionality is shown in Figure 9.

Figure 9. Smart Sensor Electronics Provides Signal Conditioning, Power Conditioning, Sensor Control, Calibration Storage, Conversion To Engineering Units and Digital Interface.

The Smart Sensor electronics currently consist of a power converter board, signal conditioning board, and a microcontroller board. The control system is based on an eight-bit microcontroller. Integrated microcontrollers are well suited for control applications of this nature due to its onboard peripherals, in particular the Programmable Counter Array. Several PCA channels are programmed to act as Pulse Width Modulators to control sensor heater elements. Another channel is used as a Watch Dog Timer to protect against errant firmware execution.

An external Address/Data bus allows for program fetches, data storage in non-volatile SRAM, and access to the Analog to Digital Converter. A reset device provides a reliable power-on reset to the CPU and also monitors Vcc. If Vcc is outside a predetermined range, the CPU is placed in reset until Vcc returns to acceptable levels. Serial communication is provided, and both RS-232 and RS-485 levels are supported. Analog sensor signals are acquired from the sensor amplifier board using an analog to digital converter. Twelve-bit resolution ensures a high degree of accuracy. Sensor
temperature data is used to provide closed loop control of the sensor temperature. The controller board is combined with a sensor amplifier board and a power supply board to produce a very compact data acquisition and control system. When assembled, the board stack measures approximately 1.3" by 2.1" by 1.2".

NASA is planning to fly a network of six sensors on an upcoming Space Shuttle mission STS-95 as part of HDT-I in November 1998 (Figure 10). The mission will evaluate new technologies to improve vehicle health monitoring. The “Smart” module to fly on this mission adds the functionality of an on-board microcontroller to provide all sensor control, conversion of data to engineering units, storage of calibration data, built-in-test functions, and communications.

The technology for this “Smart Sensor” for the STS-95 mission is significantly improved over previous designs. These improvements include a significant reduction in system integration with, for example, no centralized control system and a reduction in cabling requirements. The “Smart Sensor” performs all required sensor element control functions and provides a high level digital interface to the vehicle data system. These “Smart Sensor” modules requires only a four wire connection (two for power and two for RS-485 communications) and can be easily integrated existing avionics systems.

For the X-33 program, a 20 sensor system is being developed for use on the purge vent doors. The sensors are integrated with an electronics module which provides signal conditioning electronics and an isolated 28 VDC DC/DC power conversion. The X-33 system is currently in qualification testing including EMI, vibration, and thermal cycle testing. The X-33 is scheduled for flight testing in 1999.

Future work will include the further miniaturization of the electronics package and associated housing. The use of ASIC (application specific integrated circuits) technology is envisioned to decrease the size and weight of the electronics while maintaining the same capabilities.

COMMERCIAL APPLICATIONS

MEI is continuing this work with potential application of hydrogen sensors in a variety of industrial environments. For example, use of a hydrogen sensor to detect degradation of the health of transformers is being explored. As electrical insulation in a transformer breaks down prior to its failure, hydrogen is released. Monitoring of hydrogen in-situ in these transformers can provide early detection of transformer degradation and avoid costly catastrophic failure of transformers in the field. The PdAg sensors have already been applied to automotive leak testing applications and the complete product has been internationally recognized with a 1995 R&D 100 Award. Other possible applications include the monitoring of hydrogen releases from fuel cells and industrial safety monitoring.

SUMMARY

Leak detection technology is being developed for aerospace applications. This technology is based on microfabrication and micromachining (MEMS-based) technology and SiC semiconductor technology. The
hydrogen sensor technology, using both PdCr alloys, has been well developed and is being applied on the X-33 and on the upcoming Space Shuttle STS-95 mission. Oxygen sensor technology is also being developed to complement the hydrogen sensor technology. This micromachined oxygen sensor uses ZrO₂ to amperometrically measure the oxygen over a wide concentration range. Hydrocarbon sensor technology to detect leaks alternate fuels are also under development to meet the needs of future aerospace propulsion applications. Thus, miniaturized leak detection technology is already being applied to improve the safety of aerospace propulsion applications and integration of this technology in future propulsion systems is envisioned.

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